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SERIAL NUMBER 10/673,873	FILING DATE 09/30/2003 RULE	CLASS 438	GROUP ART UNIT 2823	ATTORNEY DOCKET NO. SEC.1084	
APPLICANTS					
Sung-Bae Lee, Hwasung-City, KOREA, REPUBLIC OF; Sang-Rok Hah, Seoul, KOREA, REPUBLIC OF; Hong-Seong Son, Suwon-City, KOREA, REPUBLIC OF;					
** CONTINUING DATA ***** <i>none</i>					
** FOREIGN APPLICATIONS ***** <i>(APR)</i> REPUBLIC OF KOREA 2003-12763 02/28/2003					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/22/2003					
Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after <i>Michelle Estrada</i> Examiner's Signature <i>APR</i> Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 11	TOTAL CLAIMS 26	INDEPENDENT CLAIMS 4
ADDRESS 20987 VOLENTINE FRANCOS, & WHITT PLLC ONE FREEDOM SQUARE 11951 FREEDOM DRIVE SUITE 1260 RESTON, VA 20190					
TITLE Method of forming a trench for use in manufacturing a semiconductor device					
FILING FEE	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of				
FEES: Authority has been given in Paper					

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